

**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q90882

Yoshinori IWABUCHI, et al.

Appln. No.: 10/553,190

Group Art Unit: 1795

Confirmation No.: 2218

Examiner: Michael A. BAND

Filed: October 13, 2005

For: METHOD FOR FORMING POROUS THIN FILM

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated July 29, 2009, please amend the above-identified application as follows on the accompanying pages.

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